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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10026120	12/21/2001	430		1752	LEE, J. S.

**APPLICANTS: Li Wenjie; Varanasi Pushkara; Kwong Raneet

**CONTINUING DATA VERIFIED:

** FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	ATTORNEY DOCKET NO
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no			FIS9-2001 0381-US
35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no			
Verified and Acknowledged Examiner's initials			
TITLE : Positive resist compositions containing non-polymeric silicon additives			

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED		
ISSUE FEE Amount Due Date Paid		Assistant Examiner		Total Claims Print Claim for O.G.
		Primary Examiner		DRAWING Sheets Drwg. Figs.Drwg. Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE		Application Examiner
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